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CONFIRMATION NO. 4340

SERIAL NUMBER 10/550,761	FILING or 371(c) DATE 01/09/2006 RULE	CLASS 438	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. ABE-034		
APPLICANTS Eiji Kamiyama, Tokyo, JAPAN; Takeo Katoh, Tokyo, JAPAN; Jea Gun Park, Seoul, KOREA, REPUBLIC OF; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/04886 04/02/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-099541 04/02/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /ROBERTS P Acknowledged CULBERT/ Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 5	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 2
ADDRESS KUBOVCIK & KUBOVCIK SUITE 710 900 17TH STREET NW WASHINGTON, DC 20006						
TITLE Laminated semiconductor substrate process for producing the same						
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		